PTC/SB/08A(10-01) Approved for use through 10/31/2002, OMB 651-0031

Substitute for form 1449A/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT 10/681481 **Application Number** October 8, 2003 Filing Date Farrar, Paul **First Named Inventor** 1746 **Group Art Unit** MAR 2 2 2003 Unknown **Examiner Name** Attorney Docket No: 1303.112US1 Sheet 1 of 1

| US PATENT DOCUMENTS | | | | | | | |
|---------------------|------------------------|------------------|--|-------|----------|----------------------------|--|
| Examiner Initial * | USP Document Number | Publication Date | Name of Patentee or Applicant of cited Document | Class | Subclass | Filing Date If Appropriate | |
| MK | US-4,817,652 | 04/04/1989 | Liu, Benjamin Y. | 134 | 102.1 | 03/26/1987 | |
| | US-4,944,837 | 07/31/1990 | Nishikawa, Masaru, et al. | 216 | 41 | 02/28/1989 | |
| | US-4,962,776 | 10/16/1990 | Liu, Benjamin Y., et al. | 134 | 11 | 05/03/1988 | |
| | US-5,185,296 | 02/09/1993 | Morita, Kiyoyuki , et al. | 438 | 694 | 04/24/1991 | |
| | US-5,304,515 | 04/19/1994 | Morita, Kiyoyuki , et al. | 437 | 231 | 08/07/1992 | |
| | US-5,900,354 | 05/04/1999 | Batchelder, John S. | 430 | 395 | 07/03/1997 | |
| | US-6,071,439 | 06/06/2000 | Bawa, Rajan S., et al. | 264 | 1.1 | 09/23/1997 | |
| | US-6,149,828 | 11/21/2000 | Vaartstra, Brian A. | 216 | 57 | 05/05/1997 | |
| | US-6,242,165 | 06/05/2001 | Vaartstra, Brian A. | 430 | 329 | 08/28/1998 | |
| | US-6,306,754 | 10/23/2001 | Agarwal, Vishnu K. | 438 | 619 | 06/29/1999 | |
| MK | US-6,666,986 | 12/23/2003 | Vaartstra, Brian A. | 252 | 79.1 | 07/14/2000 | |

| FOREIGN PATENT DOCUMENTS | | | | | | | | | |
|--------------------------|---------------------|------------------|--|-------|----------|----------------|--|--|--|
| Examiner Initials* | Foreign Document No | Publication Date | Name of Patentee or Applicant of cited Document | Class | Subclass | L ₅ | | | |

| | OTHER | R DOCUMENTS NON PATENT LITERATURE DOCUMENTS | • |
|-----------------------|--------------|---|----|
| Examiner Initials* | Cite No 1 | Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published. | T² |
| ; | | WOLF, "SILICON PROCESSING FOR THE VLSI ERA", Process Integration, Vol. I,(1989),169-171 | |

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DATE CONSIDERED

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